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Substitute Form PTO-1449 (When Filled)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 05542-149004	Application No. 09/863,118
Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b))		Applicant Manoocher Birang, et al.	
		Filing Date May 22, 2001	Group Art Unit 3723

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
LW	AA	5,196,353	03/23/93	Sandhu et al.			
	AB	5,257,478	11/02/93	Hyde et al.			
	AC	5,672,091	09/30/97	Takahashi et al.			
	AD	5,949,927	09/07/99	Tang			
	AE	6,524,164	02/25/03	Tolles			
	AF	6,537,133	03/25/03	Birang et al.			
	AG						
	AH						
	AI						
	AJ						

Foreign Patent Documents or Published Foreign Patent Applications								
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
LW	AK	JP 62190726	08/87	JP			Abstract	
	AL	JP 62211927	09/87	JP			Abstract	
	AM	JP 2222533	09/90	JP			Abstract	
	AN	JP 5138531	06/93	JP			Abstract	
	AO	FR 1075634	10/54	FR			X	

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
LW	AP	Anonymous, "Endpoint Detection of Oxide Polishing and Planarization of Semiconductor Devices, Research Disclosure No. 340, Kenneth Mason Publication, Ltd., August 1992
	AQ	Rodel, "Glass Polishing Pad", January 1993
	AR	
	AS	

Examiner Signature 	Date Considered 8/21/03
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EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.